

Practitioner's Docket No.: SUP-028 (MAL1P001)



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Chi Au et al.

Application No.: 10/615,318

Group No.: 2874

Filed: 07/07/2003

Examiner: Ellen E. Kim

For: "Optical Isolator, Attenuator And Polarizer System And Method For Integrated Optics"

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**SUBMISSION OF PROPOSED DRAWING AMENDMENT
FOR APPROVAL BY EXAMINER**

Attached please find a copy of the original Figure 1a with markings, showing the proposed changes to the drawing in this application, for which the approval of the Examiner is requested. Replacement Figure 1a without markings is also enclosed for substitution of the originally filed Figure 1a.

Date: April 4, 2006



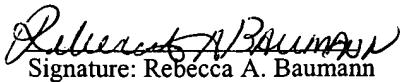
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I hereby certify that this correspondence is being deposited with the United States Postal Service as FIRST CLASS MAIL in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450 on April 4, 2006.

4/4/2006
Date


Signature: Rebecca A. Baumann